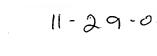
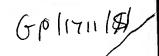
11-29-01





Attorney Docket No. UMC-96-279 CON Client/Matter No. 81848.0016.001

## N THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Coming CHEN, et al

Serial No. 09/546,174

Filed: April 11, 2000

HIGH DENSITY PLASMA CHEMICAL For:

VAPOR DEPOSITION PROCESS

1711 Examiner:

Art Unit:

R. SERGEN

PETITION FOR 2-MONTH EXTENSION OF TIME PECE 3 2001

nmissioner for Patents

Drive
22202-3513

Assistant Commissioner for Patents 2900 Crystal Drive Arlington, VA 22202-3513

Sir: The undersigned hereby petitions for a 2-month extension of time in which to respond to the Communication mailed September 11, 2001, in the above case, from October 11, 2001, to December 11, 2001. A check in the amount of \$400.00 is enclosed herewith. A full response, with possible further extension petition, will be forthcoming.

Respectfully submitted,

November 26, 2001

Carol W. Burton, Reg. No. 35,465

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